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Collective excitation of plasmonic hot-spots for enhanced hot charge carrier transfer in metal/semiconductor contacts†

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We show how a combination of near- and far-field coupling of the localised surface plasmon resonances in aluminium nanoparticles deposited on TiO₂ films greatly enhances the visible light photocatalytic activity of the semiconductor material. We demonstrate two orders of magnitude enhancement in the rate of decomposition of methylene blue under visible light illumination when the surface of TiO₂ films is decorated with gratings of Al nanoparticle dimers.

Photocatalysis with semiconductor materials has great potential for the direct conversion of solar to chemical energy. A photocatalyst material after absorbing light energy, creates highly energetic charge carriers that can drive useful chemical transformations, including production of fuels by solar energy (e.g. hydrogen from water splitting^{1–5} and hydrocarbons from CO₂ (ref. 6)), the production of high-value fine chemicals (e.g. ethylene oxide⁷) and the elimination of hazardous contaminants from air and water (e.g. nitrous oxides, etc.). Conventional photocatalytic processes are however not very efficient.⁸ Suitable semiconductor materials for photocatalysis (i) only absorb light in the UV region of the solar spectrum (less than 10% of the total available solar energy) (ii) exhibit fast recombination of the photo-excited charge carriers which additionally (iii) have small diffusion lengths, factors which add up to low photocatalytic efficiencies.

Plasmonic enhanced photocatalysis^{9–14} has resurfaced as a very effective approach for increasing the efficiency of photocatalytic processes. In this approach, nanoparticles of coinage

metals (predominantly Ag and Au) are placed either in direct contact or in the vicinity of the photocatalytic material, leading to increased generation of chemically useful electron–hole pairs as a result of several surface plasmon related mechanisms that mitigate some of the intrinsic shortcomings listed above.

One such mechanism involves the transfer of hot-electrons from metal nanoparticles into the photocatalytic material, in an analogous manner to dye sensitization in solar cells.^{15–17} Absorption of light by metal nanoparticles, through photo-excitation of localised surface plasmon resonances (LSPRs), can result (after non-radiative relaxation) in the formation of hot-electrons: a transient population of electrons with energies between the vacuum and the Fermi level of the metal.¹⁴ When the metal is in direct contact with the semiconductor material, a Schottky energy barrier ϕ_{SB} occurs (see Fig. 1) and the efficiency of hot-electron transfer is proportional to the fraction of the hot-electron population which has enough energy to overcome this barrier.¹⁸ Given that in general ϕ_{SB} is much

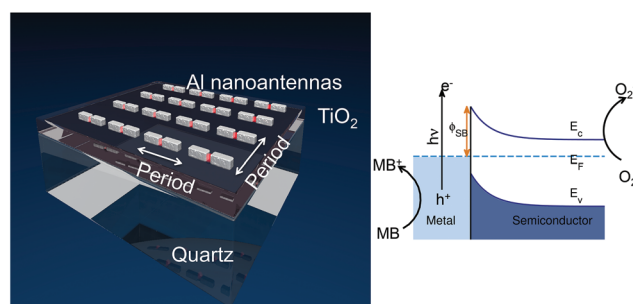


Fig. 1 Aluminium gap nanoantennas are deposited on top of 190 nm films of TiO₂. The antennas are periodically arranged on the substrate. The periodicity of the array is optimised to achieve a collective in-phase dipolar coupling on the nanoantennas. The diagram on the right illustrates the idealised energy band alignment at the metal/semiconductor interface. Non-radiative plasmon relaxation produces a hot-electron that is transferred above the Schottky barrier ϕ_{SB} to TiO₂. The charge separated state initiates charge transfer processes in solution.

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smaller than the band-gap of the semiconducting material, the generation of chemically useful¹⁶ charge carriers *via* this mechanism extends the response of the combined photocatalytic system to the visible and near-infrared regions of the spectrum.¹⁹

According to White and Catchpole,¹⁸ the metal-to-semiconductor hot-electron photo-current j_{sc} can be estimated with the following equation:

$$j_{sc} = e \int S(\lambda) \sigma_{abs}(\lambda) \eta(\lambda, \phi_{SB}) d\lambda \quad (1)$$

where e is the electron's charge, $S(\lambda)$ is the incident photon flux [number of photons/(s nm μm^2)], $\sigma_{abs}(\lambda)$ is the absorption cross-section (μm^2) of the metal nanoparticles and $\eta(\lambda, \phi_{SB})$ is the probability of hot-electron emission from the metal nanoparticles into the semiconductor material.

The Schottky barrier between Au and TiO_2 is in the order of 0.9 to 1.0 eV²⁰ which implies that the fraction of hot-electrons with sufficient energy to cross the barrier $\eta(\lambda, \phi_{SB})$ is about 20% to 40%²¹ at the wavelengths of the LSPRs¹⁸ (see the ESI†). In spite of this limitation, several reports exist where Au nanoparticles have greatly enhanced the photocatalytic activity (and photocurrents) of TiO_2 .²² The fraction $\eta(\lambda, \phi_{SB})$ of hot-electrons could be increased to >70% by using aluminium, an abundant and relatively inexpensive metal that has a more positive work function and consequently a smaller associated metal-semiconductor Schottky barrier (see detailed estimate in the ESI†).

According to eqn (1), the second parameter that affects the hot-electron photocurrent is $\sigma_{abs}(\lambda)$, the optical absorption cross section of the metal nanoparticles which can be controlled by the shape and geometrical arrangement of the metal particles. Al nanoparticles typically exhibit localised surface plasmon resonances in the UV region^{23–26} but when placed in direct contact with high refractive index materials, such as TiO_2 , these LSPRs can be shifted to the visible light.²⁷

In this communication, we have demonstrated how diffractive coupling in Al nanoparticles leads to significant enhancements in the photocatalytic activity of TiO_2 using visible light. Our approach exploits plasmonic coupling effects at two length scales to maximise visible light absorption by the plasmonic array. The concept is illustrated in Fig. 1. The unit cell of the plasmonic arrays consists of Al nanorod dimers with tip-to-tip separation distances of about 20 nm. At these deep sub-wavelength distances, near-field interactions lead to plasmonic hybridization²⁸ resulting in local electromagnetic field densities that can be many orders of magnitude higher than the incident field (*i.e.* plasmonic hot-spots),²⁹ an effect that has recently been employed for achieving one order of magnitude enhancement in surface enhanced infra-red spectroscopy.³⁰ These Al dimers are periodically arranged on the surface of the thin (190 nm) films of TiO_2 with a period that results in a collective excitation of all the dimers in the array and consequently in the absorption of light that far exceeds that of the non-interacting Al dimers.³¹

Light absorbed by these strongly coupled arrays results, after surface plasmon non-radiative relaxation, in hot charge

carrier transfer from the Al dimers to the semiconductor substrate, an efficient process for Al/ TiO_2 in the visible region of the spectrum.[‡] This charge transfer initiates redox reactions at the metal and semiconductor interfaces.

We arbitrarily choose the geometry of the unit cell of the arrays of Fig. 1 for it to exhibit particle plasmon resonances in the visible region of the spectrum. With a fixed geometry for the unit cell, the next step in the design consists of optimising the value of the periodicity of the lattice required to achieve in-phase diffractive dipole-dipole interactions:^{32–37} for a single Al dimer, the driving electromagnetic field is simply given by the incident field \vec{E}_{inc} . For a periodic array, the local field \vec{E}_{loc} that excites each nanoparticle is a superposition of the incident field and the field created by the other nanoparticles in the array:

$$\vec{E}_{loc} = \vec{E}_{inc} + \sum_p \vec{E}_p, \quad (2)$$

where the summation is implicitly defined to exclude self-interaction terms. The geometry of the plasmonic array dictates the relative contribution of the second term to the total local electric field, which can result in suppressed extinction³³ or extremely large local electric fields.³⁵

In Fig. 2(A) we show how the calculated absorption spectra change with the periodicity of the array where in addition to spectral red-shifts with increasing period, changes in the mag-

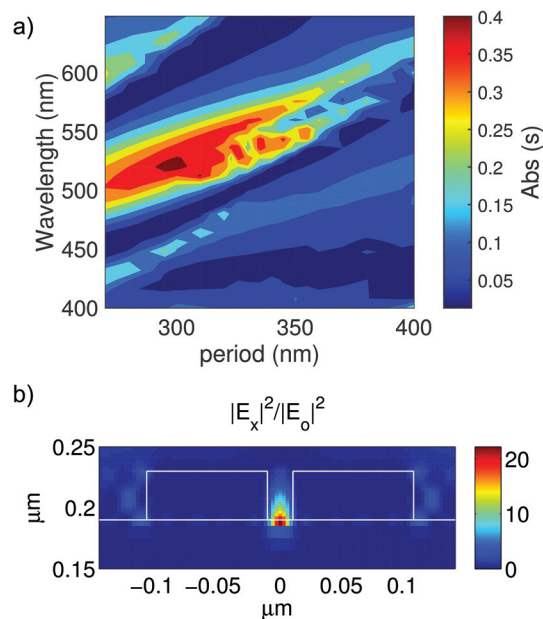


Fig. 2 (A) Calculated absorption spectra of Al dimer arrays for different periods for s polarization. The width of each nanorod was 80 nm, length 100 nm, height 40 nm and the face-to-face distance was fixed at 20 nm. The metal particles were assumed to be deposited on top of 190 nm TiO_2 thin films. (B) Calculated spatial distribution of the x-component of the electric field at the 520 nm resonance. It is clear that a plasmonic hot-spot occurs at the gap of the nanorods and furthermore most of this electric field is confined to the TiO_2 space.



nitude of the absorption are also evident. The dominant absorption band reaches a maximum for an array period of 300 nm; this enhanced absorption originates from the in-phase collective oscillation of the LSPRs of the Al dimers. These bands occur at wavelengths λ where the diffractive order (i, j) of the periodic array transitions from evanescent to radiative,³¹ a condition approximately given by:³⁶

$$\lambda \approx \frac{p}{\sqrt{i^2 + j^2}} n_{\text{TiO}_2}, \quad (3)$$

which for a period of $p = 300$ nm, a refractive index $n_{\text{TiO}_2} \sim 2.45$ and for the diffraction order for which $i = j = 1$ occurs at wavelengths around $\lambda \sim 520$ nm, a wavelength where the Al nanodimers focus electromagnetic energy very strongly at the inter-particle gap. To illustrate this point, we have shown in Fig. 2(B) a map of the x -component of the magnitude (squared) of the electric field. This represents the contribution of field enhancement due to the excitation of the longitudinal hybrid plasmon mode of the nanoparticle dimer. Due to the asymmetric dielectric environment, these hot-spots are more concentrated at the TiO_2 region.

To realise these systems that exhibit collective excitation of plasmonic hot-spots, we fabricated arrays of Al nanorod dimers using top-down electron beam lithography on glass slides coated with 190 nm TiO_2 thin films. This top-down nanofabrication approach results in naked surfaces (*i.e.* free of ligands) which favour interfacial charge transfer. A scanning electron microscopy image of one such array is shown in Fig. 3(A). In Fig. 3(B) we show the spectrum of the extinction of the array (shown as $1 - \text{transmittance}$). The spectrum exhibits many spectral features but the dominant one occurs around 520 nm in close agreement with the estimate given by eqn (2) and the numerical simulations of Fig. 2.

The spectral band at 520 nm is very narrow and intense, which is characteristic of the excitation of a collective mode with suppressed radiative damping.³⁵ The spectrum also has regions of very suppressed absorptions (at ~ 490 nm and ~ 600 nm) which could be accounted for by considering the destructive interference between the waveguided modes at the TiO_2 films and the particle plasmon resonances.^{33,38} At this 520 nm wavelength, light normally incident on the array excites a collective plasmonic oscillation which concentrates most of the electromagnetic energy on the hot spots located at the nanodimer gap [see Fig. 2(B)]. Non-radiative relaxation of this collective oscillation could result in the excitation of hot electrons on the Al nanodimers which could be transferred into the underlying TiO_2 film.

As a test of this hypothesis, we measured the rate of degradation of methylene blue (MB) by following spectroscopically a decrease in the absorption band of MB at 665 nm upon illumination with spectrally filtered light from a Hg lamp (centred at 550 nm with a 40 nm band pass). MB decomposition by TiO_2 is a convenient test reaction because it can be followed spectroscopically in the visible region of the spectrum and it is also a well understood reaction that is initiated by charge transfer

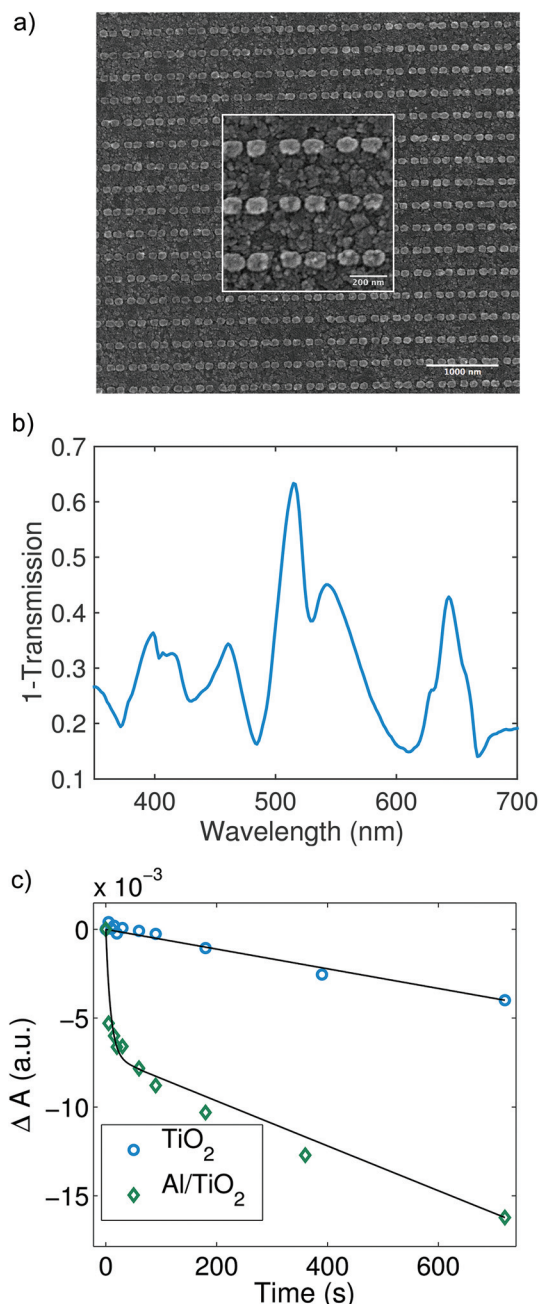


Fig. 3 (A) A scanning electron microscopy (SEM) image of a square array of Al nanodimers with a period of 300 nm, shown at two different size scales. (B) Extinction spectra ($1 - T$) of the fabricated arrays measured with unpolarised light. (C) Change in absorbance of a 50 ppm solution of methylene blue contained inside a microfluidic channel on top of a $3 \times 3 \text{ mm}^2$ array of Al nanoantenna dimers with 540 nm illumination (bandwidth of 40 nm).

processes as depicted in Fig. 1:³⁹ the Al nanoparticles inject holes into MB molecules and the TiO_2 film injects electrons into dissolved oxygen. The resulting charged species undergo a number of transformations that eventually lead to a net decomposition of MB into smaller molecules.³⁹



The measured absorbance decay (ΔA) (Fig. 3(C)) is directly proportional to the change in concentration of MB. For the bare TiO_2 substrate, the observed ΔA time decay was accurately described by a first-order kinetic decay (single exponential) yielding a rate constant of $k = 5.6 \times 10^{-6} \text{ s}^{-1}$. In contrast, for the Al nanodimer array we found that the decay was bi-exponential with rates $k_1 = 1.13 \times 10^{-1} \text{ s}^{-1}$ and $k_2 = 1.28 \times 10^{-5} \text{ s}^{-1}$, which are $\sim 10^4$ and ~ 2 times higher than the one obtained for the bare TiO_2 substrate. An average decay rate $\langle k \rangle = 8.18 \times 10^{-4} \text{ s}^{-1}$ can be estimated from the bi-exponential fit^{||} which is about 150 times larger than the one observed for the bare TiO_2 substrate (which exhibits a low rate due to its poor absorption of visible light). This result would seem to confirm our hypothesis and furthermore, it seems to imply that hole transfer from Al nanoparticles to MB molecules in solution [see Fig. 1] occurs in spite of the documented evidence that Al nanoparticles self-terminate with a 3–5 nm oxide layer when exposed to ambient air.²⁶

We have demonstrated how the periodic arrangement of metal nanoparticles on a photocatalytic substrate leads to strong collective plasmon resonances. These strong optical responses are translated into augmented rates of hot-electron generation and consequent enhanced redox reaction rates. Our proof-of-concept demonstration is not just limited to variations in the periodicity of deposited nanostructures; in contrast, lithographic nanofabrication enables unparalleled control over the geometry of the nanoparticles, which we anticipate to have as yet to be explored effects on the enhancement of photochemical processes.

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† See the ESI†

‡ Full details in the ESI†

¶ Details of measurement and data processing in the ESI†

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